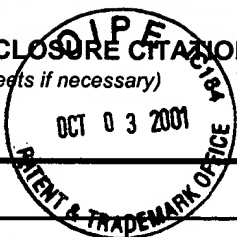


<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)	ATTY DOCKET NO. <b>50060-00040</b>	SERIAL NO. <b>09/840,716</b>
	<b>SNIEGOWSKI ET AL</b>	
	FILING <b>4/23/01</b>	GROUP <b>1765</b>



**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A	5,766,367	6/16/98	SMITH ET AL	134	2	
B	5,783,340	7/21/98	FARINO ET AL	430	22	
C	5,798,283	8/25/98	MONTAGUE ET AL	438	24	
D	5,804,084	9/8/98	NASBY ET AL	216	2	
E	5,867,302	2/2/99	FLEMING	359	291	
F	5,919,548	7/6/99	BARRON ET AL	428	138	
G	5,955,801	9/21/99	ROMERO ET AL	310	40 MM	
H	5,959,376	9/28/99	ALLEN	310	40 MM	
I	5,963,788	10/5/99	BARRON ET AL	438	48	
J	5,990,473	11/23/99	DICKEY ET AL	250	231.13	
K	5,994,801	11/30/99	GARCIA	310	40 MM	

**FOREIGN PATENT DOCUMENTS**

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO

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 OCT 5 2001  
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**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

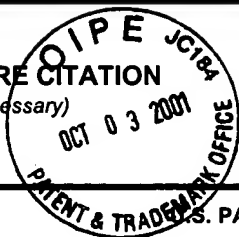
O	NEE ET AL; "STRETCHED-FILM MICROMIRRORS FOR IMPROVED OPTICAL FLATNESS"; JANUARY, 2000 IEEE MEMS - 2000 CONFERENCE, MIYAZAKI, JAPAN

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

# INFORMATION DISCLOSURE CITATION

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ATTY DOCKET NO.

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09/840,716

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*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LV	L	6,012,336	11/11/00	EATON ET AL	73	754	
LV	M	6,020,272	2/1/00	FLEMING	438	734	
LV	N	6,082,208	7/4/00	RODGERS ET AL	74	406	4/1/98

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## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

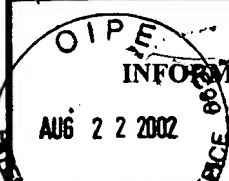

EXAMINER

LAN VINH

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6/19/2003

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**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional) <b>50060-000</b>	Application Number <b>09/840,716</b>
Applicant(s) <b>SNIEGOWSKI ET AL.</b>	
Filing Date <b>4/23/01</b>	Group Art Unit <b>1765</b>

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LV	AA	5,637,539	6/10/97	HOFMANN ET AL.	438	20	
LV	AB	5,550,090	8/27/96	RISTIC ET AL.	437	228	

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER <b>LAN VINH</b>	DATE CONSIDERED <b>6/19/2003</b>
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